



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: **Kenichi HIGUCHI**

Serial No.: **10/654,979**

Group Art Unit: **UNASSIGNED**

Filed: **September 5, 2003**

Examiner: **UNASSIGNED**

For: **METHOD FOR ETCHING ORGANIC INSULATING FILM AND METHOD FOR  
FABRICATING SEMICONDUCTOR DEVICE**

**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 CFR 1.97(b)(4)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 5, 2003

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each of these documents is attached.

No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the issuance of a first official action on the merits in the above-identified patent application.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. See 37 CFR 1.104(a) concerning the PTO duty to consider and use any such information. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commissioner is authorized to charge our Deposit Account No. 50-2866 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

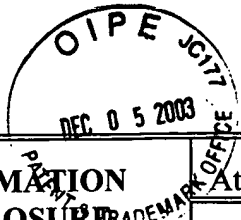
A handwritten signature in black ink, appearing to read 'Stephen G. Adrian', is written over the printed name.

Stephen G. Adrian  
Attorney for Applicants  
Reg. No. 32,878

Enclosures: PTO-1449; and 1 reference

Attorney Docket No. **031110**  
1250 Connecticut Avenue, N.W.  
Suite 700  
Washington, D.C. 20036  
Telephone: (202) 822-1100

SGA/arf



<b>INFORMATION DISCLOSURE CITATION PTO-1449</b>	Atty. Docket No. <b>031110</b>	Serial No. <b>10/654,979</b>
	Applicant(s): <b>Kenichi HIGUCHI</b>	
	Filing Date: <b>September 5, 2003</b>	Group Art Unit: <b>Unassigned</b>

### U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					

### FOREIGN PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Country	Translation (Yes or No)	
_____	AC	2001-110784	04/2001	Japan	Abstract
_____	AD				
_____	AE				
_____	AF				
_____	AG				
_____	AH				
_____	AI				

### OTHER DOCUMENTS

_____	AJ	
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Examiner		Date Considered